Filed on behalf of: LG Electronics, Inc. and

LG Electronics U.S.A., Inc.

Paper \_\_\_\_

By: Brian A. Tollefson, Lead Counsel

Date filed: April 14, 2016

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## UNITED STATES PATENT AND TRADEMARK OFFICE

## BEFORE THE PATENT TRIAL AND APPEAL BOARD

LG ELECTRONICS, INC., and LG ELECTRONICS U.S.A., INC., Petitioner

v.

TOSHIBA SAMSUNG STORAGE TECHNOLOGY KOREA CORPORATION,
Patent Owner

Case IPR2015-01653 Patent RE43,106

DECLARATION OF MICHAEL H. JONES IN SUPPORT OF PETITIONER'S MOTION FOR ADMISSION PRO HAC VICE



Mail Stop PATENT BOARD Patent Trial and Appeal Board U.S. Patent & Trademark Office P.O. Box 1450 Alexandria, VA 22313-1450

- I, Michael H. Jones, declare as follows:
- 1. I have been practicing in the field of intellectual property, and particularly, patent litigation, for approximately six years.
- I am a member in good standing of the Bars of the District of
   Columbia and the State of Virginia. I am admitted to practice in the United States
   Court of Appeals for the Federal Circuit.
- 3. I have been in private practice and litigating patent cases since 2010. I also served as a summer law clerk working on various patent matters under the supervision of attorneys in 2008 and 2009.
- 4. I have never been suspended or disbarred from practice before any court or administrative body.
- 5. I have never had a court or administrative body deny my application for admission to practice.
- 6. No sanctions or contempt citations have ever been imposed against me by any court or administrative body.



- 7. I have read and will comply with the Office Patent Trial Practice Guide and the Board's Rules of Practice for Trials, as set forth in Part 42 of 37 C.F.R.
- 8. I agree to be subject to the USPTO Rules of Professional Conduct set forth in 37 C.F.R. §§ 11.101 *et seq.* and disciplinary jurisdiction under 37 C.F.R. § 11.19(a). I also agree to be subject to the USPTO Rules of Professional Conduct as set forth in Changes to Representation of Others Before the United States Patent and Trademark Office; Final Rule, 78 Fed. Reg. 20180 (Apr. 3, 2013) (effective May 3, 2013).
- 9. In the past three (3) years, I have not been admitted *pro hac vice* in any proceedings before the United States Patent and Trademark Office.
- 10. I am familiar with the subject matter at issue in this proceeding. I am counsel in the *LG Electronics, Inc. and LG Electronics U.S.A., Inc. v. Toshiba Samsung Storage Technology Korea Corporation* (Case No. 1:12-cv-01063-LPS-CJB) and *Toshiba Samsung Storage Technology Korea Corporation v. LG Electronics, Inc., LG Electronics U.S.A., Inc. and LG International (America), Inc.* (Case No. 1:15-cv-00691-LPS-CJB), both patent infringement litigations, which are pending in the United States District Court for Delaware and involve the patent at issue in this proceeding.



11. I hereby declare that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements are made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code and that such willful false statements may jeopardize the validity of U.S. Patent No. RE43,106.

Date: April 14, 2016

By: Michael H. Jones

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## **CERTIFICATE OF SERVICE**

I hereby certify that on this 14<sup>th</sup> day of April, 2016, a true and correct copy of the foregoing DECLARATION OF MICHAEL H. JONES IN SUPPORT OF PETITIONER'S MOTION FOR ADMISSION *PRO HAC VICE* was served, via electronic mail upon the following counsel for Patent Owner Toshiba Samsung Storage Technology Korea Corporation:

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| Erik van Leeuwen |

Erik van Leeuwen Litigation Operations Coordinator Rothwell, Figg, Ernst & Manbeck, P.C.

